



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 31, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG833649473

LABORATORY GROWN DIAMOND

OVAL BRILLIANT

9.41 x 6.32 x 3.86 mm

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.43 CARAT

E

FLAWLESS

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

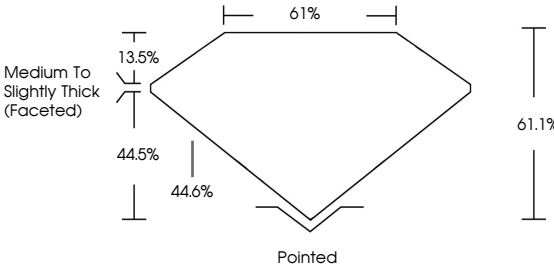
 LG833649473

 LG833649473

LG833649473

Report verification at [igi.org](https://www.igi.org)

PROPORTIONS



Medium To Slightly Thick (Faceted)



Sample Image Used

LIGHT PERFORMANCE REPORT

Light Performance Grade: **Exceptional**



Structured Light Environment Representation

Moderate

High

Superior

Exceptional

Light Performance



Brightness



Fire



Contrast



COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included





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IGI

August 31, 2026

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OVAL BRILLIANT

9.41 X 6.32 X 3.86 MM

Carat Weight

Color Grade

Clarity Grade

Table

Depth

Girdle

1.43 CARAT

E

FLAWLESS

61.1%

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

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